

Form 1449*	Atty. Docket No.: 303.377US3	Serial No. Unknown
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)	Applicant: Kie Y. Ahn et al.	
	Filing Date: Herewith	Group: Unknown

U. S. PATENT DOCUMENTS

**Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Applicable
MG	4,981,820	01/01/1991	Renlund, G.M., et al.	501	39	07/28/89
MG	5,103,288	04/07/1992	Sakamoto, M., et al.	357	71	03/27/91
MG	5,177,567	01/05/1993	Klersy, P.J., et al.	257	4	07/19/91
MG	5,180,694	01/19/1993	Renlund, G.M., et al.	501	12	08/30/90
MG	5,380,553	01/10/1995	Loboda, M.J.	427	226	12/24/90
MG	5,470,802	11/28/1995	Gnade, B.E., et al.	437	238	05/20/94
MG	5,525,857	06/11/1996	Gnade, B., et al.	313	309	08/19/94
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**Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No
MG	0684642	11/29/1995	European			

OTHER DOCUMENTS

**Examiner Initial	(Including Author, Title, Date, Pertinent Pages, Etc.)
MG	Anand, M., et al., "NURA: A Feasible, Gas-Dielectric Interconnect Process", <u>Symp. on VLSI Technology Digest of Technical Papers</u> , 82-83, (1996)
MG ✓	Anderson, R., et al., "Porous Polycrystalline Silicon: A New Material for MEMS", <u>J. Microelectromechanical Systems</u> , 3, 10-18, (March 1994)

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*Substitute Disclosure Statement Form (PTO-1449)

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MG	Singh, A., et al., "Porous Silicon Oxycarbide Glasses", <u>J. Am. Ceram. Soc.</u> , 79, 2696-2704, (1996)
MG	Togo, M., et al., "A Gate-side Air-gap Structure (GAS) to Reduce the Parasitic Capacitance in MOSFETs", <u>Symp. on VLSI Technology Digest of Technical Papers</u> , 38-39, (1996)
MG	Watanabe, H., et al., "A Novel Stacked Capacitor with Porous-Si Electrodes for High Density DRAMs", <u>1993 Symposium on VLSI Technology, Digest of Technical Papers</u> , Kyoto, Japan, 17-18, (1993)

Examiner	Date Considered
<i>Maria Guerrero</i>	<i>15-31-02</i>

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Sheet 1 of 1

Form 1449*

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INFORMATION DISCLOSURE STATEMENT
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Applicant: Kie Y. Ahn et al.

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**Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date	
						If Appropriate	
MG	5,448,015	01/30/1996	Havemann, R.H., et al.	174	68.3	05/20/94	
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**Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
MG	0775669	✓ 05/28/1997	European	C01B	13/32		
MG	0849796	✓ 06/24/1998	European	H01L	23/532		
MG	10-150033	✓ 06/02/1998	Japan	H01L	21/312 with English Abstract		

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